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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Attorney Docket No.: SON-1745

Seiichi FUKUDA

Application No.: 09/512,336

Examiner: K. Chen

Filed: February 24, 2000

Art Unit: 1765

For: DRY ETCHING METHOD AND METHOD OF
MANUFACTURING SEMICONDUCTOR APPARATUS

**PETITION TO EXTEND TIME FOR
RESPONSE TO WITHIN THE THIRD EXTENDED MONTH**

RECEIVED
JUN 13 2002
TC 1765

Commissioner of Patents
Washington, D.C. 20231

Sir:

Applicants respectfully petition the Commissioner of Patents and Trademarks to extend the time for response to the final Office Action dated December 31, 2001, for three (3) months from March 31, 2002 to June 31, 2002.

The Commissioner is hereby authorized to charge \$920.00 to Deposit Account 18-0013 to cover the petition fee for a large entity.

The Commissioner is also authorized to charge any additional fees associated with this communication to Deposit Account No. 18-0013. A duplicate copy of this letter is enclosed for that purpose.

06/11/2002 TGEDAMU1 00000069 180013 09512336

01 FC:117 920.00 CH

Respectfully submitted,

Dated: June 7, 2002

David K. Benson
Reg. No. 42,314

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